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APPLICATION NO.	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.
10/627,081	07/24/2003	Yoshio Sasaki	B-5163 621099-6	3130
36716	7590	04/06/2006	EXAMINER	
LADAS & PARRY 5670 WILSHIRE BOULEVARD, SUITE 2100 LOS ANGELES, CA 90036-5679				GUPTA, PARUL H
ART UNIT		PAPER NUMBER		
2627				

DATE MAILED: 04/06/2006

Please find below and/or attached an Office communication concerning this application or proceeding.

<b>Office Action Summary</b>	<b>Application No.</b>	<b>Applicant(s)</b>
	10/627,081	SASAKI ET AL.
	<b>Examiner</b> Parul Gupta	<b>Art Unit</b> 2627

-- The MAILING DATE of this communication appears on the cover sheet with the correspondence address --

#### Period for Reply

A SHORTENED STATUTORY PERIOD FOR REPLY IS SET TO EXPIRE 3 MONTH(S) OR THIRTY (30) DAYS, WHICHEVER IS LONGER, FROM THE MAILING DATE OF THIS COMMUNICATION.

- Extensions of time may be available under the provisions of 37 CFR 1.136(a). In no event, however, may a reply be timely filed after SIX (6) MONTHS from the mailing date of this communication.
- If NO period for reply is specified above, the maximum statutory period will apply and will expire SIX (6) MONTHS from the mailing date of this communication.
- Failure to reply within the set or extended period for reply will, by statute, cause the application to become ABANDONED (35 U.S.C. § 133). Any reply received by the Office later than three months after the mailing date of this communication, even if timely filed, may reduce any earned patent term adjustment. See 37 CFR 1.704(b).

#### Status

- 1) Responsive to communication(s) filed on 24 July 2003.
- 2a) This action is **FINAL**.                    2b) This action is non-final.
- 3) Since this application is in condition for allowance except for formal matters, prosecution as to the merits is closed in accordance with the practice under *Ex parte Quayle*, 1935 C.D. 11, 453 O.G. 213.

#### Disposition of Claims

- 4) Claim(s) 1-12 is/are pending in the application.
  - 4a) Of the above claim(s) \_\_\_\_\_ is/are withdrawn from consideration.
- 5) Claim(s) \_\_\_\_\_ is/are allowed.
- 6) Claim(s) 1-12 is/are rejected.
- 7) Claim(s) \_\_\_\_\_ is/are objected to.
- 8) Claim(s) \_\_\_\_\_ are subject to restriction and/or election requirement.

#### Application Papers

- 9) The specification is objected to by the Examiner.
- 10) The drawing(s) filed on \_\_\_\_\_ is/are: a) accepted or b) objected to by the Examiner.  
Applicant may not request that any objection to the drawing(s) be held in abeyance. See 37 CFR 1.85(a).  
Replacement drawing sheet(s) including the correction is required if the drawing(s) is objected to. See 37 CFR 1.121(d).
- 11) The oath or declaration is objected to by the Examiner. Note the attached Office Action or form PTO-152.

#### Priority under 35 U.S.C. § 119

- 12) Acknowledgment is made of a claim for foreign priority under 35 U.S.C. § 119(a)-(d) or (f).
  - a) All    b) Some \* c) None of:
    1. Certified copies of the priority documents have been received.
    2. Certified copies of the priority documents have been received in Application No. \_\_\_\_\_.
    3. Copies of the certified copies of the priority documents have been received in this National Stage application from the International Bureau (PCT Rule 17.2(a)).

\* See the attached detailed Office action for a list of the certified copies not received.

#### Attachment(s)

- |  |   |
|--|---|
| 1) <input checked="" type="checkbox"/> Notice of References Cited (PTO-892)  | 4) <input type="checkbox"/> Interview Summary (PTO-413)                     |
| 2) <input type="checkbox"/> Notice of Draftsperson's Patent Drawing Review (PTO-948)   | Paper No(s)/Mail Date. _____.   |
| 3) <input checked="" type="checkbox"/> Information Disclosure Statement(s) (PTO-1449 or PTO/SB/08)<br>Paper No(s)/Mail Date _____. | 5) <input type="checkbox"/> Notice of Informal Patent Application (PTO-152) |
|  | 6) <input type="checkbox"/> Other: _____.                                   |

## DETAILED ACTION

1. Claims 1-12 are pending for examination as interpreted by the examiner. The IDS filed on 7/24/03 was considered.

### ***Specification***

2. The disclosure is objected to because of the following informalities: minor typographical errors such as the use of "characteristics" instead of "characteristic" in paragraph 0058, "coincides" instead of "coincide" in paragraph 0076, and "lever" instead of "level" in paragraph 0085. Appropriate correction is required. Applicant's cooperation is requested in correcting any other errors of which applicant may become aware in the specification.

### ***Claim Rejections - 35 USC § 103***

The following is a quotation of 35 U.S.C. 103(a) which forms the basis for all obviousness rejections set forth in this Office action:

(a) A patent may not be obtained though the invention is not identically disclosed or described as set forth in section 102 of this title, if the differences between the subject matter sought to be patented and the prior art are such that the subject matter as a whole would have been obvious at the time the invention was made to a person having ordinary skill in the art to which said subject matter pertains. Patentability shall not be negated by the manner in which the invention was made.

3. Claims 1, 2, 4-5, 10, 11, and 12 are rejected under 35 U.S.C. 103(a) as being unpatentable over Yanagawa, US Patent Publication 2001/0026522 in view of Yamanaka, US Patent 6,771,584.

Regarding claim 1, Yanagawa teaches a spherical aberration correcting apparatus comprising: a correction amount deciding unit ("system control circuit" of element 6 in figure 2) configured to decide an optimum correction amount of the spherical aberration so as to minimize the spherical aberration; and a spherical

aberration correcting unit ("servo control circuit" of element 5 in figure 2) configured to correct the spherical aberration according to the optimum correction amount of the spherical aberration.

Regarding claim 11, Yanagawa teaches an information recording system comprising: a spherical aberration correcting apparatus, a correcting amount deciding unit ("system control circuit" of element 6 in figure 2) configured to decide an optimum correcting amount of the spherical aberration so as to minimize the spherical aberration, and a spherical aberration correcting unit ("servo control circuit" of element 5 in figure 2) configured to correct the spherical aberration according to the optimum correcting amount of the spherical aberration; and a control unit ("system control circuit" of element 6 in figure 2 also serves this purpose) configured to, when detecting that the optical recording medium is set to the information recording apparatus, make control the spherical aberration correcting apparatus to correct the spherical aberration.

Regarding claim 12, Yanagawa teaches a spherical aberration correcting method comprising the steps of: deciding an optimum correction amount of the spherical aberration so as to minimize the spherical aberration (paragraph 0039); and correcting the spherical aberration according to the optimum correction amount of the spherical aberration (paragraph 0039).

Yanagawa does not but Yamanaka teaches an apparatus with a test recording unit configured to perform a test recording on an optical recording medium (column 15, lines 36-41); a characteristic obtaining unit ("variable frequency characteristic amplifier" of element 15 in figure 9) configured to obtain a characteristic corresponding to a parameter by the test recording, the parameter being correlated with a spherical

aberration and minimizes the spherical aberration according to the characteristic of the parameter ("performs correction in the frequency band of the signal output" of column 15, lines 47-55). The method of performing these functions is taught in column 15 lines 36-55.

It would have been obvious to one of ordinary skill in the art at the time of the invention to include the concept of test recording to obtain a characteristic of a parameter as taught by Yamanaka into the system of Yanagawa. This would yield a method and apparatus capable of correcting spherical aberration without giving rise to an increase in scale of the apparatus or an increase of the cost (column 3, lines 1-7).

Regarding claim 2, Yamanaka teaches a spherical aberration correcting apparatus according to claim 1, wherein the characteristic obtaining unit comprises: a reproducing element configured to reproduce a signal recorded by the test recording to generate a reproduced signal (column 15, lines 36-45), and an obtaining element configured to obtain the characteristic according to the reproduced signal (column 15, lines 46-55).

Regarding claim 4, Yamanaka teaches a spherical aberration correcting apparatus according to claim 1, wherein the characteristic obtaining unit is configured to obtain the characteristic corresponding to the parameter while the test recording unit performs the test recording (column 15, lines 47-55).

Regarding claim 5, Yanagawa teaches a spherical aberration correcting apparatus according to claim 4, wherein the characteristic obtaining unit is configured to detect a pit level ("detected light from the pits") as the parameter according to a light

reflected from the optical recording medium (column 5, lines 20-28) while the test recording unit performs the test recording (test recording described in column 15, lines 47-55), and to obtain the characteristic of the pit level (column 5, lines 20-28).

Regarding claim 7, Yamanaka teaches a spherical aberration correcting apparatus, wherein the test recording unit makes change to an amount of the spherical aberration within a range in which a predetermined value of the parameter is included (done by ‘optical aberration correction element’ of element 14 and “variable frequency characteristic amplifier” of element 15 of figure 9 as explained in column 15, lines 47-55) while performing the test recording (column 15, lines 36-45), the predetermined value of the parameter being set to correspond to a minimum of the spherical aberration (obvious based on design of apparatus).

Regarding claim 10, Yamanaka teaches a spherical aberration correcting apparatus according to claim 1, wherein the test recording unit is configured to perform the test recording immediately before a recording of information on the optical recording medium (column 15, lines 36-41).

4. Claims 3 and 8 rejected under 35 U.S.C. 103(a) as being unpatentable over Yanagawa in view of Yamanaka as applied to claims 1 and 7 above, and further in view of Hayashi et al., US Patent Publication 2001/0040853.

Yanagawa in view of Yamanaka teaches a spherical aberration correcting apparatus according to the limitations of claims 1 and 7.

Regarding claim 3, Yanagawa in view of Yamanaka does not but Hayashi et al. teaches a spherical aberration correcting apparatus, wherein the parameter includes at

least one of a jitter (given in paragraph 0045), a  $\beta$  value, a modulation, an asymmetry and a recording power.

Regarding claim 8, Yanagawa in view of Yamanaka does not but Hayashi et al. a spherical aberration correcting apparatus, wherein the parameter includes a jitter, and the predetermined value of the jitter is minimum (given in paragraphs 0044 and 0045).

It would have been obvious to one of ordinary skill in the art at the time of the invention to factor jitter as taught by Hayashi et al. into the apparatus of Yanagawa in view of Yamanaka. Thus, jitter can be detected irrespective of the sizes of the detection areas of the photodetector (paragraph 0046 of Hayashi et al.).

5. Claim 6 is rejected under 35 U.S.C. 103(a) as being unpatentable over Yanagawa in view of Yamanaka as applied to claim 4 above, and further in view of Furukawa, US Patent 6,643,230.

Yanagawa in view of Yamanaka teaches the spherical aberration correcting apparatus of claim 4. In addition, Yanagawa in view of Yamanaka teaches the characteristic obtaining unit ("variable frequency characteristic amplifier" of element 15 in figure 9) and the test recording unit performs the test recording (column 15, lines 46-55), and to obtain the characteristic of the pit ratio ("signal output").

Yanagawa in view of Yamanaka does not but Furukawa teaches a spherical aberration correcting apparatus, configured to detect a pit level (a similar method of gaining the "residual error value" is explained in the given section) and at least one of a read level, a write level and a recording power (a similar method of gaining the "amplitude width value of the disturbance signal" is explained in the given section) according to a light reflected from the optical recording medium, the parameter including

the pit level, the read level, the write level and the recording power, the pit ratio representing the ratio of one of the read level or the write level to the pit level (column 3, line 60-column 4, line 25).

It would have been obvious to one of ordinary skill in the art at the time of the invention to include the spherical aberration correction apparatus utilizing the pit value and pit ratio of Furukawa into the apparatus of Yanagawa in view of Yamanaka. This would create accurate reading of information even if spherical aberration were generated by the thickness error in the transparent substrate of an optical disk (column 1, lines 31-35 of Furukawa).

6. Claim 9 is rejected under 35 U.S.C. 103(a) as being unpatentable over Yanagawa in view of Yamanaka as applied to claim 7 above, and further in view of Nishi, US Patent Publication 2004/0174781.

Yanagawa in view of Yamanaka teaches a spherical aberration correcting apparatus according to the limitations of claim 7.

Yanagawa in view of Yamanaka does not but Nishi teaches a spherical aberration correcting apparatus according to claim 7, wherein the parameter includes a  $\beta$  value ("amplitude of the shortest mark" is similar to  $\beta$  value), and the predetermined value of the  $\beta$  value is maximum (paragraph 0118).

### ***Conclusion***

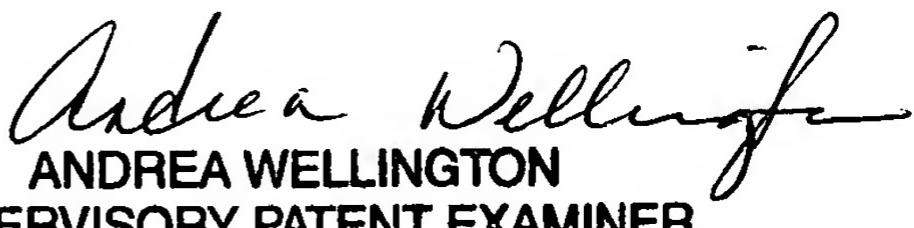
7. The prior art made of record and not relied upon is considered pertinent to applicant's disclosure. Shintani et al., US Patent 6922386 teaches a similar method of spherical aberration correction in the test recording unit.

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Parul Gupta whose telephone number is 571-272-5260. The examiner can normally be reached on Monday through Thursday, from 8:30 AM to 7 PM.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Andrea Wellington can be reached on 571-272-4483. The fax phone number for the organization where this application or proceeding is assigned is 571-273-8300.

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see <http://pair-direct.uspto.gov>. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

PHG  
3/30/06

  
ANDREA WELLINGTON  
SUPERVISORY PATENT EXAMINER